

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Hideya TAKEO, et al.

Docket No: Q77911

Appln. No.: 10/684,708

Group Art Unit: 2624

Confirmation No.: 3651

Examiner: Sean T. MOTSINGER

Filed: October 15, 2003

For: ABNORMAL PATTERN CANDIDATE DETECTION PROCESSING METHOD AND
SYSTEM

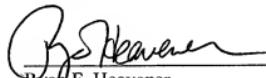
STATEMENT UNDER 37 C.F.R. § 1.704(d)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in a communication from a foreign patent office in a counterpart foreign application, and that the communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of said Information Disclosure Statement.

Respectfully submitted,



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23373

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Date: July 23, 2008